

AUG 06 2003
PATENT & TRADEMARK OFFICE
GR 00 P 1583

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By: JPZ

Date: 8/4/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Klaus Lowack et al.

Applic. No. : 09/817,963

Filed : March 27, 2001

Title : Method For The Metalization Of An Insulator
And/Or A Dielectric

Examiner : Brian K. Talbot

Group Art Unit : 1762

A M E N D M E N T

Hon. Commissioner of Patents and Trademarks,
Washington, D. C. 20231

S i r :

Responsive to the Office action dated April 4, 2003 kindly
amend the above-identified application as follows:

08/07/2003 AWONDAF1 00000076 09817963

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